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BIBDATASHEET

Bib Data Sheet

CONFIRMATION NO. 7441

SERIAL NUMBE 09/754,841			1 .	LASS 250	GROUP ART UNIT 2878		JNIT	ATTORNEY DOCKET NO. (Z) 98027 P US		
APPLICANTS										
Michael Gerhard, Aalen, GERMANY;										
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This application is a CIP of PCT/EP99/04210 06/17/1999										
** FOREIGN APPLICATIONS ************************************										
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 03/29/2001										
35 USC 119 (a-d) conditions yes no Met after Allowance						SHEETS TO			INDEPENDENT	
Verified and Acknowledged								IMS 0	CLAIMS 2	
ADDRESS M. Robert Kestenbaum 11011 Bermuda Dunes NE Albuquerque , NM 87111										
TITLE Process for the decontamination of microlithographic projection exposure devices										
						☐ All Fees				
						☐ 1.16 Fees (Filing) ☐ 1.17 Fees (Processing Ext. of				
	No.	10, to charge dealt be contributed in					time)			
RECEIVED 840	No for following:					1.18 Fees (Issue)				
							Other			